



Docket: 0756-935



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Phylos D Caldwell

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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT application of	)
Shunpei YAMAZAKI et al.	)
Serial No. 08/160,909	) Art Unit: 1107 ,
Filed: December 3, 1993	) wilczuski
For: METHOD OF FABRICATING	)
SEMICONDUCTOR DEVICES AND	)
APPARATUS FOR PROCESSING	)
A SEMICONDUCTOR	)

## **REQUEST FOR STATUS**

Honorable Commissioner of Patents and Trademarks Washington, D.C. 20231

Sir:

To date the undersigned attorney of record has received no action in the above-identified patent application. Please provide the undersigned with a status report of the application.

Respectfully submitted,

Gerald J. Ferguson, Jr.

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